

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 4, 2025

IGI Report Number

LG732533496

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

PRINCESS CUT

Measurements

8.12 X 7.92 X 5.53 MM

GRADING RESULTS

Carat Weight

3.04 CARATS

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

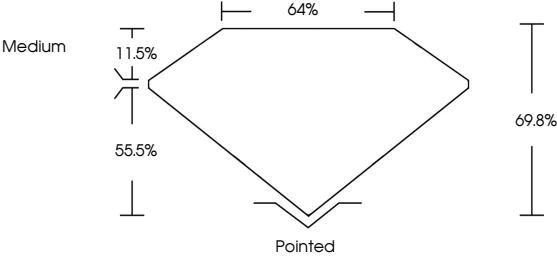
Inscription(s)

 LG732533496

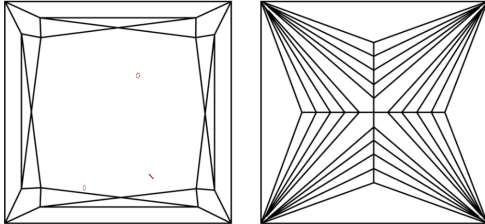
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS ¹⁻²

VS ¹⁻²

SI ¹⁻²

I ¹⁻³



Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included


Included



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
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IGI

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PRINCESS CUT

8.12 X 7.92 X 5.53 MM

3.04 CARATS

E

Carat Weight

3.04 CARATS

Color Grade

E

Clarity Grade

VS 1

Depth

55.5%

Table

11.5%

Girdle

Medium

Culet

Pointed

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

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